


TRANSMITTAL

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Title of Invention	A METHOD FOR SUPERCRITICAL CARBON DIOXIDE PROCESSING OF FLUORO-CARBON FILMS	
Application Number :	10/711649	
Date :	2004-09-29	
First Named Applicant:	Kawamura Kohei	
Confirmation Number:	5648	
Attorney Docket Number:	SSIT-114	
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Submitted By:		Elec. Sign.
Kristi L. Davidson Registered Number: 44643		/Kristi L. Davidson/ Attorney

Documents being submitted:	Files
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